

**PATENT**  
**CUSTOMER NO.: 32,425**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Karin Scherer et al.

Serial No.: 10/523,951

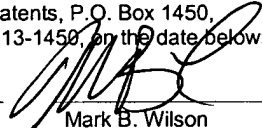
Filed: February 8, 2005

For: METHOD FOR OBTAINING A THIN,  
STABILIZED FLUORINE-DOPED  
SILICA LAYER, RESULTING THIN  
LAYER, AND USE THEREOF IN  
OPHTHALMIC OPTICS

Group Art Unit: 2874

Examiner: Unknown

Atty. Dkt. No.: ESSR:090US

<b>CERTIFICATE OF MAILING</b> 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
January 5, 2006	
Date	Mark B. Wilson

**INFORMATION DISCLOSURE STATEMENT**

**MS AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R §§ 1.97(g), (h), this Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

The present Information Disclosure Statement is being filed prior to the receipt of a first Official Action reflecting an examination on the merits, and hence is believed to be timely filed in accordance with 37 C.F.R § 1.97(b). No fees are believed to be due in connection with the filing of this Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these materials, the Commissioner is authorized to deduct the appropriate fees from Fulbright & Jaworski Deposit Account No.: 50-1212/ESSR:090US.

Applicants respectfully request that the listed documents be made of record in the present case.

Respectfully submitted,



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Date: January 5, 2006



Form PTO-1449 (modified)

List of Patents and Publications for Applicant's

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty. Docket No.

ESSR:090US

Serial No.

10/523,951

Applicant

Karin Scherer et al.

Filing Date:

February 8, 2005

Group:

2874

U.S. Patent Documents

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Foreign Patent Documents

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Other Art

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## U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.

## Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	EP 0 975 017	1/26/00	Europe			
	B2	EP 11264903	9/28/99	Japan			Abstract
	B3	JP 05215929	8/27/93	Japan			Abstract
	B4	WO 02/11195	2/7/02	WIPO			Abstract

## Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	Lee and Hwangbo, "Inhomogeneous refractive index of SiO <sub>x</sub> thin films prepared by ion beam assisted deposition," <i>Surface and Coatings Technology</i> , 128-129:280-285, 2000.

25536164.1

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.